




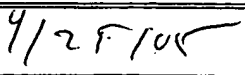


Form PTO-1449 (Modified)		U.S. Department of Commerce Patent and Trademark Office	Atty. Docket No. Intel/14492	Serial No. 10/673,534
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)			Applicant Raghuram Narayan	
			Filing Date September 29, 2003	Group Art Unit 2874

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)		
	C01	Timothy Day, Frank Luecke, Michael Brownell, <i>Continuosly Tunable Diode Lasers</i> , New Focus, Inc., Mountain View, California, Lasers & Optronics, June 1993, 6 pages
	C02	F.J. Duarte, <i>Multiple-prism granting designs tune diode lasers</i> , Laser Focus World, February 1993, pp. 103-109
	C03	M. de Lebachellerie, G. Passedat, <i>Mode-hop suppression of Littrow granting-tuned lasers</i> , Applied Optics Vol. 32, No. 3, January 20, 1993, pp. 269-274
	C04	Michael G. Littman, <i>Single-Mode Operation of Grazing-Incidence Pulsed Dye Laser</i> , Optical Society of America, Optics Letters, Vol. 3, No. 4, October 1978, pp.138-140
	C05	<i>82 nm of Continuous Tunability for an External Cavity Semiconductor Laser</i> , Electronics Letters, Vol. 27, No. 2, January 17, 1991, pp.183-184
	C06	Dr. Timothy Day, <i>External Cavity Tunable Lasers for Network Deploymen</i> , New Focus, Inc., San Jose, California, IEEE 2001 0-7803-7100-3/01, March 2001, pp.39-40
	C07	Haim Lotem, <i>Littrow-Mounted Diffraction Granting Cavity</i> , Applied Optics, Vol. 33, No. 6, February 20, 1994, pp.930-934
	C08	Paul Zorabedian, <i>Characteristics of a Granting-External-Cavity Semiconductor Laser Containing Intracavity Prism Beam Expanders</i> , Jurnal of Lightware Technology, Vol. 10, No. 3, March 1992, pp.330-335
	C09	W.R. Trutna, L.F. Strokes, <i>Continuously Tuned External Cavity Semiconductor Laser</i> , Jurnal of Lightware Technology, Vol. 11, No. 8, August 1993, pp. 1279-1286

EXAMINER 	DATE CONSIDERED 
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance <u>and</u> not considered. Include copy of this form with next communication to applicant.	